Client Code: IRDM.029CPCDD

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| 4 New Section 1 12 November 1 | |
|---|--|
| Name of conveying party(ies): (List using letters or numbers for multiple parties) | Name and address of receiving party(ies): |
| Iridigm Display Corporation | Name: IDC, LLC |
| Additional name(s) of conveying party(ies) | Internal Address: Street Address: 2415 Third Street |
| attached? | City: San Francisco State: CA |
| () Yes (X) No | ZIP: 94107 |
| | Additional name(s) of receiving party(ies) attached? |
| Nature of conveyance: (X) Assignment () Security Agreement () Merger () Change of Name | () Yes (X) No |
| () Other: Execution Date: (List as in section 1 if multiple | US or PCT Application number(s) or US Patent number(s): |
| signatures) November 4, 2004 | (X) Patent Application No.: 10/844,802 Filing Date: May 12, 2004 |
| | Additional numbers attached? |
| | () Yes (X) No |
| Party to whom correspondence concerning document should be mailed: | Total number of applications and patents involved: 1 |
| Customer No. 20,995 | |
| Address: Knobbe, Martens, Olson & Bear, LLP 2040 Main Street, 14 th Floor Irvine, CA 92614 Return Fax: (949) 760-9502 Attorney's Docket No.: IRDM,029CPCDD | |
| 7. Total fee (37 CFR 1.21(h)): \$40.00 | 8. Deposit account number: 11-1410 |
| (X) Authorized to be charged to deposit account | Please charge this account for any additional fees which may be required, or credit any overpayment to this account. |
| Statement and signature. | |
| To the best of my knowledge and belief, the foregoing is a true copy of the original document. Mark M. Abumeri | information is true and correct, and any attached copy Marcha 8 2005 |
| Name of Person Signing Signa | ature Date |
| 43,458 Registration No. | |
| Total number of pages including cover s | sheet, attachments and document 12 |
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PATENT

REEL: 015854 FRAME: 0262

ASSIGNMENT

WHEREAS, IRIDIGM DISPLAY CORPORATION (hereinafter "ASSIGNOR"), a Delaware corporation, having a principal place of business 2415 Third Street, San Francisco, California 94107, has certain rights in Improvements in interferometric modulation, for which several Applications for Patents have been or may be filed and/or several Patents have been issued in the United States and internationally, a list of which is set forth in Exhibit A attached herero.

AND WHEREAS, IDC, LLC (hereinafter "ASSIGNEE"), a Delaware limited liability company, with its principal place of business at 2415 Third Street, San Francisco, CA. 94107, desires to acquire ASSIGNOR'S entire right, title, and interest in and to (1) said Improvements, including said Applications and Patents listed in Exhibit A, AND (2) all subject matter in which ASSIGNOR had rights on or prior to October 1, 2004, which is not particularly identified in Exhibit A (hereinafter "Intellectual Property"), including (i) all inventions, ideas, concepts, designs, materials, methods or processes, and the like, whether or not parentable, (ii) all know-how and trade secrets, whether or not qualifying as trade secret(s), and (iii) all improvements, modifications, or developments relating to any of said Intellectual Property;

NOW, THEREFORE, for good and valuable consideration, the receipt of which is hereby acknowledged. ASSIGNOR does hereby acknowledge that it has sold, assigned, transferred and set over on October 1, 2004, and by these presents does hereby sell, assign, transfer and set over with an effective assignment date of October 1, 2004, and by these ASSIGNEE, its successors, legal representatives and assigns, ASSIGNOR's entire right, title, and interest throughout the world in, to and under the said Improvements and Intellectual Property, including the said Applications and Patents and all non-provisionals, divisions, renewals and continuations thereof, and all Patents of the United States which may have been or may be granted thereon and all reissues and extensions thereof, and all rights of priority under International Conventions and applications for Patents which may hereafter be filed for said Improvements and Intellectual Property in any country or countries foreign to the United States, and all Patents which may be granted for said Improvements and Intellectual Property in any country or countries foreign to the United States, whose duty it is to issue patents on applications as aforesaid, to issue all Patents for said Improvements and Intellectual Property to the said ASSIGNEE, its successors, legal representatives and assigns, in accordance with the terms of this instrument;

AND ASSIGNOR HEREBY sells, assigns, transfers, and conveys to ASSIGNEE, its successors, legal representatives, and assigns all claims for damages and all remedies arising out of any violation of the rights assigned hereby that may have accrued prior to the date of assignment to ASSIGNEE, or may accrue hereafter, including, but not limited to, the right to sue for, collect, and retain damages for past infringements of said Patent, before or after issuance;

AND ASSIGNOR HEREBY covenants and agrees that it will communicate to the said ASSIGNEE, its successors, legal representatives and assigns, any facts known to it respecting said Improvements and Intellectual Property, and will designate an individual on its behalf to testify in any legal proceeding, sign all lawful papers, execute all divisional, communing and reissue applications, make all rightful oaths and generally do everything possible to aid the said ASSIGNEE, its successors, legal representatives and assigns, to obtain and enforce proper patent protection for said Improvements and Intellectual Property in all countries;

NOTWITHSTANDING the foregoing provisions, this instrument shall not affect any of ASSIGNOR's rights in said Improvements and Intellectual Property, as licensed by ASSIGNEE to ASSIGNOR in a Patent License Agreement entered between ASSIGNEE and ASSIGNOR on October 1, 2004.

IN TESTIMONY WHEREOF, I hereunto set my hand and seal this day of November

1 day of November 2004

GREG HEINZINGER

Page 1 of

Assignment, having an effective date of October 1, 2004, from Iridigm Display Corporation to IDC, LLC

| TITLE | Country | Application No. | Filing Date |
|--|---------|-----------------|-------------|
| ALTERING TEMPORAL RESPONSE OF MICROELECTROMECHANICAL ELEMENTS | S | 10/794,737 | 3/3/2004 |
| DRIVER VOLTAGE ADJUSTER | S | 10/772,120 | 02/03/04 |
| INTEGRATED MODULATOR ILLUMINATION | SU | 10/794,825 | 03/05/04 |
| MEMS DEVICES WITH UNRELEASED THIN FILM COMPONENTS | US . | 10/700,641 | 11/03/03 |
| MODIFYING THE ELECTRO-MECHANICAL BEHAVIOR OF DEVICES | S | 10/839,307 | 05/04/04 |
| INTERFEROMETRIC MODULATORS WITH THIN FILM TRANSISTORS | SU | 10/883,902 | 07/02/04 |
| METHOD OF MANUFACTURE FOR MICROELECTROMECHANICAL DEVICES | S | 10/839,329 | 05/04/04 |
| IMOD ARRAY WITH INTEGRATED OPTICAL COMPENSATION STRUCTURE | S | 60/541,607 | 02/03/04 |
| METHOD FOR OPTIMIZING COLOR IN IMOD DISPLAYS | SU | 60/550,687 | 03/06/04 |
| LOW CAPACITANCE MEMS DEVICE | SU | 10/909,228 | 07/29/04 |
| METHODS OF ADDRESSING A BI-STABLE MODULATOR | SU | 60/604,896 | 08/27/04 |
| METHODS OF ADDRESSING A BI-STABLE MODULATOR | SU | 60/606,223 | 08/31/04 |
| CURRENT MODE DISPLAY DRIVER | S | 60/604,893 | 08/27/04 |
| SENSING STATUS OF A MEMS MEMORY DEVICE | S | 60/604,892 | 08/27/04 |
| INTERFEROMETRIC MODULATION | PCT | PCT/US96/17731 | 11/06/96 |
| INTERFEROMETRIC MODULATION OF RADIATION | S | 10/844,802 | 05/13/04 |

Assignment, having an effective date of October 1, 2004, from Iridigm Display Corporation to IDC, LLC

| TITLE | Country | Application No. | Filing Date |
|---|---------|-----------------|-------------|
| SEPARABLE MODULATOR | PCT | PCT/US04/02645 | 08/12/04 |
| SEPARABLE MODULATOR | Talwan | 93124794 | 08/18/04 |
| METHOD FOR FABRICATING A STRUCTURE FOR A MICROELECTROMECHANICAL SYSTEMS (MEMS) DEVICE | ß | 10/941,042 | 09/14/04 |
| A METHOD FOR FABRICATING A STRUCTURE FOR A MICROELECTROMECHANICAL SYSTEMS | China | 2828414.3 | 04/29/02 |
| A METHOD FOR FABRICATING A STRUCTURE FOR A MICROELECTROMECHANICAL SYSTEMS | Europe | 2725847,4 | 04/29/02 |
| A METHOD FOR FABRICATING A STRUCTURE FOR A MICROELECTROMECHANICAL SYSTEMS | Japan | 2003-568475 | 04/29/02 |
| A METHOD FOR FABRICATING A STRUCTURE FOR A MICROELECTROMECHANICAL SYSTEMS | Korea | 2004-7012516 | 04/29/02 |
| PHOTONIC MEMS AND STRUCTURES | Korea | 2004-7000433 | 07/10/01 |
| MICROELECTROMECHANICAL SYSTEMS DEVICE AND METHOD FOR FABRICATING SAME | China | 2828352.X | 04/29/02 |
| MICROELECTROMECHANICAL SYSTEMS DEVICE AND METHOD FOR FABRICATING SAME | Europe | 2806893.0 | 04/29/02 |
| MICROELECTROMECHANICAL SYSTEMS DEVICE AND METHOD FOR FABRICATING SAME | Japan | Unknown | 04/29/02 |
| MICROELECTROMECHANICAL SYSTEMS DEVICE AND METHOD FOR FABRICATING SAME | Korea | 2004-7013279 | 04/29/02 |

Assignment, having an effective date of October 1, 2004, from Iridigm Display Corporation to IDC, LLC Exhibit A

| The second case of october 1, 2004, Hom Hungm Display Corporation | grdsra m | _ | TO LUC, LLC |
|--|----------|-----------------|-------------|
| TITLE | Country | Application No. | Filing Date |
| THIN FILM PRECURSOR STACK FOR MEMS AND MANUFACTURING | PCT | PCT/US04/02003 | 06/23/04 |
| AREA ARRAY MODULATION AND LEAD REDUCTION IN INTERFEROMETRIC MODULATORS | S | 10/731,989 | 12/09/03 |
| VISIBLE SPECTRUM MODULATOR ARRAYS | S | 10/082,397 | 08/06/02 |
| A SHORT PULSE METHOD FOR DRIVING AN IMOD | SU | 60/613418 | 09/27/04 |
| MINI-ENVIRONMENT RELEASE CHAMBER/POD SYSTEM | S | 60/613417 | 09/27/04 |
| SYSTEM AND METHOD OF EMBEDDING DISPLAY OPTICS | S | 60/613482 | 09/27/04 |
| DEVICE AND METHOD FOR SUPPORTING INTERFEROMETRIC MODULATORS | S | 60/613405 | 09/27/04 |
| METHOD OF PACKAGING INTERFEROMETRIC MODULATORS AND MATERIALS THEREFOR | S | 60/613493 | 09/27/04 |
| METHOD AND SYSTEM FOR DETECTING LEAK IN ELECTRONIC DEVICES | S | 60/613385 | 09/27/04 |
| DEVICE AND METHOD FOR INTERFEROMETRIC MODULATION HAVING "OXIDESTOPS" | S | 60/613466 | 09/27/04 |
| CONTROLLER AND DRIVER FEATURES FOR BI-STABLE DISPLAYS | S | 60/613412 | 09/27/04 |
| DEVICE FOR AND METHOD USING ONE OR MORE PIXEL ARCHITECTURES | S | 60/613500 | 09/27/04 |
| METHOD AND SYSTEM FOR PACKAGING A MEMS DEVICE | S | 60/613275 | 09/27/04 |
| METHOD AND DEVICE FOR LIGHTING A DISPLAY | S | 60/613264 | 09/27/04 |
| METHOD AND DEVICE FOR CORNER INTERFEROMETRIC MODULATION | હ | 60/613597 | 09/27/04 |

Assignment, having an effective date of October 1, 2004, from Iridigm Display Corporation to IDC, LLC

| o , o | ender a m | ourgin property corporation to IDC, LLC | אלי דוניר |
|--|-----------|---|-------------|
| TITLE | Country | Application No. | Filing Date |
| DISPLAY DEVICE HAVING AN ARRAY OF SPATIAL LIGHT MODULATORS WITH INTEGRATED COLOR FILTERS | S | 60/613542 | 09/27/04 |
| METHOD AND DEVICE FOR INHIBITING TILTING OF A MIRROR | SU | 60/613558 | 09/27/04 |
| INTERFEROMETRIC MODULATOR ARRAY WITH INTEGRATED MEMS ELECTRICAL SWITCHES | S. | 60/613501 | 09/27/04 |
| DEVICE HAVING A CONDUCTIVE LIGHT ABSORBING MASK AND METHOD FOR FABRICATING SAME | SU | 60/613480 | 09/27/04 |
| SEPARABLE MODULATOR | SU | 60/613372 | 09/27/04 |
| METHOD AND DEVICE FOR SELECTIVE ADJUSTMENT OF HYSTERESIS WINDOW | S | 60/613382 | 09/27/04 |
| PIXEL ELEMENT WITH SUB-PIXELS HAVING DIFFERING ACTUATION VOLTAGES | SU | 60/613458 | 09/27/04 |
| METHOD OF MAKING PRESTRUCTURE FOR MEMS SYSTEMS | SU | 60/613411 | 09/27/04 |
| INTERFEROMETRIC MODULATORS HAVING CHARGE PERSISTENCE | S | 60/613420 | 09/27/04 |
| DEVICE AND METHOD FOR DISPLAY MEMORY USING MANIPULATION OF MECHANICAL RESPONSE | જ | 60/613450 | 09/27/04 |
| DEVICE AND METHOD FOR MANIPULATION OF THERMAL RESPONSE IN A MODULATOR | SU | 60/613552 | 09/27/04 |
| METHOD FOR AND ELECTRONIC DEVICES UTILIZING MICROELECTROMECHANICAL SYSTEM | SU | 60/613465 | 09/27/04 |
| METHOD AND DEVICE FOR DRIVING INTERFEROMETRIC MODULATORS | S | 60/613483 | 09/27/04 |
| METHOD AND DEVICE FOR COMPENSATING FOR COLOR SHIFT AS A FUNCTION OF ANGLE OF VIEW | S | 60/613978 | 09/27/04 |

Assignment, having an effective date of October 1, 2004, from Tridiom Display Comparation to IDC 11 C

| Assignment, naving an elective date of October 1, 2004, from Indigm Display Corporation to IDC, LLC | im Displa | y Corporation to l | DC, LLC |
|---|-----------|--------------------|-------------|
| TITLE | Country | Application No. | Filing Date |
| APPARATUS AND METHOD FOR TUNING THE SPECTRAL RESPONSE OF LIGHT SOURCES FOR INTERFEROMETRIC MODULATORS | SU | 60/613297 | 09/27/04 |
| SYSTEM AND METHOD FOR ILLUMINATING INTERFEROMETRIC MODULATORS USING BACKLIGHTING | SU | 60/613536 | 09/27/04 |
| INTERFEROMETRIC MODULATORS CAPABLE OF RENDERING MULTIPLE OUTPUTS | SU | 60/613486 | 09/27/04 |
| METHOD AND POST STRUCTURES FOR INTERFEROMETRIC MODULATION | S | 60/613471 | 09/27/04 |
| METHOD AND DEVICE FOR WAVELENGTH FILTERING | S | 60/613403 | 09/27/04 |
| METHOD AND DEVICE FOR PACKAGING A SUBSTRATE | S | 60/613318 | 09/27/04 |
| METHOD AND DEVICE FOR PACKAGING INTERFEROMETRIC MODULATORS WITH HERMETIC BARRIER | S | 60/613476 | 09/27/04 |
| METHOD AND SYSTEM FOR PACKAGING A DISPLAY | S | 60/613563 | 09/27/04 |
| SYSTEM AND METHOD FOR DISPLAY DEVICE WITH END-OF-LIFE PHENOMENA AND RELAXED CONSTRAINT FOR HUMIDITY SENSITIVITY | SU | 60/613485 | 09/27/04 |
| SYSTEM AND METHOD FOR PROTECTING MICRO-STRUCTURE OF DISPLAY ARRAY USING SPACERS IN GAP WITHIN DISPLAY DEVICE | S | 60/613682 | 09/27/04 |
| SYSTEM AND METHOD FOR PROTECTING MICRO-STRUCTURE OF DISPLAY ARRAY USING STRUCTURALLY REINFORCED BACK-PLATE | S | 60/613408 | 09/27/04 |
| METHOD AND SYSTEM FOR REGENERATION OF MEMS DEVICE MONOLAYER | SU | 60/613564 | 09/27/04 |
| METHOD OF FABRICATING INTERFEROMETRIC MODULATORS USING PHOTOSENSITIVE POLYMERS | SU | 60/6/13401 | 09/27/04 |

Assignment, having an effective date of October 1, 2004, from Iridigm Display Corporation to IDC, LLC

| Comment of the second of the s | Professe and | wight Display Corporation Wil | (WIDC, EAC |
|--|--------------|-------------------------------|-------------|
| TITLE | Country | Application No. | Filing Date |
| METHODS AND APPARATUS FOR TESTING INTERFEROMETRIC MODULATORS | S | 60/613537 | 09/27/04 |
| OPTICS SYSTEM SUBSTRATE WITH OPTICAL FILTER | SU | 60/613481 | 09/27/04 |
| METHOD FOR AND DEVICE HAVING A PARTIALLY REFLECTIVE MIRROR IN INTERFEROMETRIC MODULATION | S | 60/613488 | 09/27/04 |
| METHOD AND SYSTEM FOR DRIVING INTERFEROMETRIC MODULATORS | S | 60/613319 | 09/27/04 |
| INTERFEROMETRIC MODULATOR MODIFICATIONS FOR SUPERIOR IMAGE QUALITY | S | 60/613499 | 09/27/04 |
| METHOD AND DEVICE FOR MANIPULATING COLOR IN A DISPLAY | S | 60/613491 | 09/27/04 |
| EXTERNAL OPTICAL FILM FOR INTERFEROMETRIC MODULATOR SYSTEM | S | 60/613535 | 09/27/04 |
| SYSTEM AND METHOD FOR ILLUMINATION INTERFEROMETRIC MODULATOR DISPLAY | S | 60/613951 | 09/27/04 |
| SYSTEM AND METHOD FOR IMPLEMENTATION OF INTERFEROMETRIC MODULATOR DISPLAYS | SU | 60/613298 | 09/27/04 |
| METHOD AND DEVICE FOR MULTI-LEVEL BRIGHTNESS IN INTERFEROMETRIC MODULATION | S | 60/613539 | 09/27/04 |
| METHOD AND SYSTEM FOR SENSING LIGHT USING INTERFEROMETRIC ELEMENTS | SS | 60/613624 | 09/27/04 |
| METHOD AND SYSTEM FOR TILING AND DISPLAY USING INTERFEROMETRIC DEVICES | S | 60/613487 | 09/27/04 |
| METHOD AND DEVICE FOR DRIVING INTERFEROMETRIC MODULATORS WITH HYSTERESIS | S | 60/613419 | 09/27/04 |

| Assignment, having an effective date of October 1, 2004, from Iridigm Display Corporation | gm Displa | | to IDC, LLC |
|---|-----------|-----------|-------------|
| TITLE | Country | | Filing Date |
| METHOD OF FABRICATING INTERFEROMETRIC DEVICES USING LIFT-OFF PROCESSING TECHNIQUES | S | 60/613496 | 09/27/04 |
| SYSTEM AND METHOD FOR DISPLAY DEVICE WITH INTEGRATED DESICCANT | S | 60/613300 | 09/27/04 |
| SYSTEM AND METHOD FOR DISPLAY WITH ACTIVATED DESICCANT | S | 60/613280 | 09/27/04 |
| SYSTEM AND METHOD OF REMOVING WATER VAPOR DURING ASSEMBLY OF MEMS DEVICE | હ | 60/613956 | 09/27/04 |
| SYSTEM AND METHOD OF INTEGRATING APPLICATION OF DESICCANT IN MEMS PROCESSING | હ | 60/613484 | 09/27/04 |
| SYSTEM AND METHOD OF PROVIDING MEMS DEVICE WITH SELF-ALIGNED MONOLAYER ON MIRROR SURFACES | ଞ | 60/613852 | 09/27/04 |
| SYSTEM AND METHOD FOR MANUFACTURING MEMS IN AN AMBIENT ENVIRONMENT | SU | 60/613467 | 09/27/04 |
| METHOD AND SYSTEM FOR PROVIDING MEMS DEVICE PACKAGE WITH SECONDARY SEAL | SU | 60/613527 | 09/27/04 |
| SYSTEM AND METHOD FOR OPTIMIZING DESICCANT USAGE IN A MEMS DEVICE | S | 60/613801 | 09/27/04 |
| SYSTEM AND METHOD OF TESTING HUMIDITY IN A SEALED MEMS DEVICE | S | 60/613567 | 09/27/04 |
| PLATED METAL SEAL FOR SMALL DIAMETER DISPLAYS | SU | 60/613569 | 09/27/04 |
| METHOD AND APPARATUS FOR POST-PACKAGING RELEASE ETCHING OF INTERFEROMETRIC ARRAYS | S | 60/613320 | 09/27/04 |
| METHOD AND STRUCTURE FOR PROTECTING DEPOSITED MEMS STRUCTURES | US | 60/613406 | 09/27/04 |

| Assignment, having an effective date of October 1, 2004, from Iridigm Display Corporation to IDC, LLC | m Display | V Corporation to I | DC LLC |
|---|-----------|--------------------|-------------|
| TITLE | Country | Application No. | Filing Date |
| METHOD AND DEVICE FOR A DISPLAY HAVING TRANSPARENT COMPONENTS INTEGRATED THEREIN | S | 60/613290 | 09/27/04 |
| METHOD AND SYSTEM FOR MAINTAINING PARTIAL VACUUM IN DISPLAY DEVICE | S | 60/613502 | 09/27/04 |
| DISPLAY DEVICE PROTECTIVE PACKAGING PRIOR TO SACRIFICIAL MATERIAL ETCH | હ | 60/613377 | 09/27/04 |
| REFLECTIVE DISPLAY DEVICE HAVING VIEWABLE DISPLAY ON BOTH SIDES | S | 60/613323 | 09/27/04 |
| REFLECTIVE DISPLAY DEVICE HAVING VIEWABLE DISPLAY ON BOTH SIDES | S | 60/613593 | 09/27/04 |
| SYSTEM AND METHOD FOR PROVIDING THERMAL COMPENSATION FOR AN INTERFEROMETRIC MODULATOR DISPLAY | SU | 60/613452 | 09/27/04 |
| REFLECTIVE DISPLAY PIXELS DEPOSITED IN NON-RECTANGULAR ARRAYS | S | 60/613853 | 09/27/04 |
| DISPLAY DEVICE FABRICATED ON EMBOSSED SUBSTRATE | S | 60/613376 | 09/27/04 |
| METHOD AND DEVICE FOR PROVIDING A DRIVER CHIP USING A BACKPLATE | SU | 60/613977 | 09/27/04 |
| METHOD OF FABRICATING A FREE-STANDING MICRO-STRUCTURE | S | 60/613299 | 09/27/04 |
| METHOD OF SELECTIVE ETCHING OF AL-CONTAINING MATERIAL USING ETCH STOP LAYER | SU | 60/613410 | 09/27/04 |
| METHOD AND DEVICE FOR INVERSE TYPE INTERFEROMETRIC MODULATION WITH OPAQUE SUBSTRATE | S | 60/613566 | 09/27/04 |
| METHOD AND SYSTEM FOR XENON FLUORIDE ETCHING WITH ENHANCED EFFICIENCY | S | 60/613423 | 09/27/04 |

| Assignment, having an effective date of October 1, 2004, from Iridigm Display Corporation to IDC, LLC | ym Display | y Corporation to I | DC,LLC |
|---|------------|--------------------|-------------|
| TITLE | Country | Application No. | Filing Date |
| METHOD FOR AND DEVICE HAVING THROUGH BACKPLATE CONNECTION TO BUSSES | S | 60/613477 | 09/27/04 |
| PRINTED CIRCUIT BOARD BASED BACKPLATES FOR OPTICAL ARRAYS | SU | 60/613489 | 09/27/04 |
| DEVICE HAVING PATTERNED SPACERS FOR BACKPLATES AND METHOD OF MAKING THE SAME | SU | 60/613478 | 09/27/04 |
| INTERFEROMETRIC OPTICAL MODULATOR USING FILLER MATERIAL AND METHOD | SU | 60/613475 | 09/27/04 |
| SYSTEM AND METHOD FOR INTERFEROMETRIC OPTICAL MODULATOR AND DIFFUSER | S | 60/613568 | 09/27/04 |
| COMPOSITE MIRROR AND MIRROR LAYER FOR OPTICAL MODULATOR AND METHOD | ᅜ | 60/613538 | 09/27/04 |
| SYSTEM AND METHOD FOR PROVIDING THERMAL COMPENSATION FOR AN INTERFEROMETRIC MODULATOR DISPLAY | S | 60/613610 | 09/27/04 |
| METHOD AND DEVICE FOR PROTECTING INTERFEROMETRIC : MODULATORS FROM ELECTROSTATIC DISCHARGE | S | 60/613492 | 09/27/04 |
| SYSTEM HAVING DIFFERENT UPDATE RATES FOR DIFFERENT PORTIONS OF A PARTITIONED DISPLAY | SU | 60/613573 | 09/27/04 |
| METHOD AND SYSTEM FOR SERVER CONTROLLED DISPLAY PARTITIONING AND REFRESH RATE | S | 60/613407 | 09/27/04 |
| SYSTEM WITH SERVER BASED CONTROL OF CLIENT DEVICE DISPLAY FEATURES | S | 60/614360 | 09/27/04 |
| METHOD AND DEVICE FOR B⊩STABLE DISPLAY | SU | 60/613617 | 09/27/04 |
| METHOD AND DEVICE FOR REDUCING POWER IN INTERFEROMETRIC MODULATION ARRAY | S | 60/613404 | 09/27/04 |

Assignment, having an effective date of October 1, 2004, from Iridigm Display Corporation to IDC, LLC Exhibit A

| rassignificate, naving an effective date of October 1, 2004, from fridigm Display Corporation to IDC, LLC | gm Displa | y Corporation to I | DC, LLC |
|---|-----------|--------------------|-------------|
| TITLE | Country | Application No. | Filing Date |
| METHOD AND SYSTEM FOR SERVER CONTROL OF DRIVER FOR DISPLAY OF CLIENT DEVICE | S | 60/613494 | 09/27/04 |
| SYSTEM AND METHOD FOR PROVIDING A VARIABLE REFRESH RATE OF AN INTERFEROMETRIC MODULATOR DISPLAY | ଞ | 60/613526 | 09/27/04 |
| SYSTEM AND METHOD FOR PROVIDING A MEMS RF VARIABLE ATTENUATOR | S | 60/613409 | 09/27/04 |
| METHOD AND DEVICE FOR REFLECTIVE DISPLAY WITH TIME SEQUENTIAL COLOR ILLUMINATION | S | 60/613375 | 09/27/04 |
| METHOD AND DEVICE FOR GENERATING WHITE IN AN INTERFEROMETRIC MODULATOR DISPLAY | S | 60/613504 | 09/27/04 |
| METHOD AND DEVICE FOR ELECTRICALLY PROGRAMMABLE DISPLAY SEGMENTS | S | 60/613379 | 09/27/04 |
| METHOD AND DEVICE FOR ION IMPLANTED CAVITY WALL FOR MODIFYING ACTUATION AND RELEASE VOLTAGE THRESHOLDS OF A DEFORMABLE MEMBRANE | <u>.</u> | 60/613451 | 09/27/04 |
| SYSTEMS AND METHODS FOR INTERFEROMETRIC MODULATION | S | 60/613891 | 09/27/04 |
| SYSTEM AND METHOD FOR INTERFEROMETRIC MODULATION | S | 60/614032 | 09/27/04 |

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